



04-21-06

ITW

<b>AMENDMENT TRANSMITTAL LETTER</b>			Docket No. 108298718US		
Application No: 10/733,523-Conf. #9060	Filing Date December 10, 2003	Examiner D. P. Turocy	Art Unit 1762		
Applicant(s): Beaman et al.					
Invention: METHODS AND SYSTEMS FOR CONTROLLING TEMPERATURE DURING MICROFEATURE WORKPIECE PROCESSING, E.G., CVD DEPOSITION					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
<b>Total Claims</b>	27	- 41 =		x	
<b>Independent Claims</b>	4	- 6 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>50-0665</u> as described below.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Chen Liang Attorney/Agent Reg. No.: 51,945			Dated: <u>April 20, 2006</u>		
PERKINS COIE LLP P.O. Box 1247 Seattle, Washington 98111-1247 (206) 359-8000					



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: KEVIN L. BEAMAN ET AL.  
APPLICATION NO.: 10/733,523  
FILED: DECEMBER 10, 2003  
FOR: **METHODS AND SYSTEMS FOR  
CONTROLLING TEMPERATURE  
DURING MICROFEATURE  
WORKPIECE PROCESSING, E.G., CVD  
DEPOSITION**

EXAMINER: DAVID P. TUROCY  
ART UNIT: 1762  
CONF. NO: 9060

**Amendment Under 37 C.F.R. § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated January 20, 2006 in the above-identified application. Please amend the application as reflected in the following list of claims.